9-20-04  
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<b>TRANSMITTAL FORM</b>  (to be used for all correspondence after initial filing)	Application Number	09/932,003	
	Filing Date	August 17, 2001	
	First Named Inventor	Cem Basceri	
	Art Unit	2813	
	Examiner Name	Y.B. Huynh	
Total Number of Pages in This Submission	6+ref.	Attorney Docket Number	MI22-1731

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Date	9/17/04

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EV372467590

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. ....09/932,003  
Filing Date .....August 17, 2001  
Inventor ..... Cem Basceri  
Assignee .....Micron Technology, Inc.  
Group Art Unit.....2813  
Examiner .....Y. B. Huynh  
Attorney's Docket No. ....MI22-1731  
Customer No. ....021567

Title: Methods of Forming Capacitor Constructions Comprising Perovskite-Type Dielectric Materials With Different Amount of Crystallinity Regions

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

References - - See attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

The citations listed may be material to the examination of the subject application and are therefore submitted in compliance with the duty of disclosure defined in 37 CFR '1.56. Copies of the cited art are included. No admission is made regarding whether all the submitted references are prior art. The Examiner is requested to make these citations of official record in this application.

This Supplemental Information Disclosure Statement is being filed after the submission of a Request for Continued Examination (RCE) and before the mailing of a first Office Action, therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Citation of these references is respectfully requested.

Respectfully submitted,

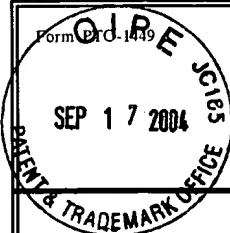
Date: \_\_\_\_\_

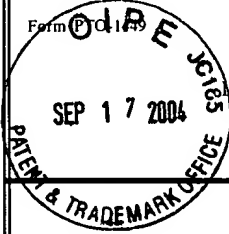
9/17/04



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Form PTO 147 <b>SEP 17 2004</b> U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1731		SERIAL NO. 09/932,003				
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)								
APPLICANT Cem Basceri				FILING DATE Aug. 17, 2001				
				GROUP 2813				
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	4,261,698	04/81	Carr et al.				
	AB	4,691,662	09/87	Roppel et al.				
	AC	5,261,961	11/93	Takasu et al.				
	AD	5,270,241	12/93	Dennison et al.				
	AE	5,312,783	05/94	Takasaki et al.				
	AF	5,392,189	02/95	Fazan et al.				
	AG	5,395,771	03/95	Nakato				
	AH	5,468,687	11/95	Carl et al.				
	AI	5,525,156	06/96	Manada et al.				
	AJ	5,614,018	03/97	Azuma et al.				
	AK	5,656,329	08/97	Hampden-Smith				
	AL	5,663,089	09/97	Tomozawa et al.				
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AM	EP 0 030 798	06/81	EPO - Hughes			N/A	
	AN	GB 2 194 555 A	03/88	UK - Nippon			N/A	
	AO	EP 0 306 069 A2	03/89	EPO - Phillips			N/A	
	AP	EP 0 388 957 A2	09/90	EPO - NEC Corp			N/A	
	AQ	JP 2250970	10/90	Japan - NEC Corp			ABS	
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AR		Aoyama et al., "Leakage Current Mechanism of Amorphous and Polycrystalline Ta <sub>2</sub> O <sub>5</sub> Films Grown by chemical Vapor Deposition,"					
			1995, pages 977-983.					
	AS		Stemmer et al., "Accommodation of nonstoichiometry in (100) fiber-textured ... thin films grown by chemical vapor deposition,"					
			©1999 American Institute of Physics, pages 2432-2434.					
	AT		Streiffer et al., "Ferroelectricity in thin films: The dielectric response of fiber-textured ...thin films grown by chemical vapor deposition,"					
			©1999 American Institute of Physics, pages 45654575.					
EXAMINERs				DATE CONSIDERED				
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				GROUP 2813			
U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	5,702,562	12/97	Wakahara			
	AB	5,719,417	02/98	Roeder et al.			
	AC	5,723,361	03/98	Azuma et al.			
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
	AM	JP 04-24922	01/92	Japan - Mitsubishi		X	
	AN	JP 04-115533	04/92	Japan - Oki Elec.		X	
	AO	JP 04-180566	06/92	Japan - Mitsushita		ABS	
	AP	JP 08-060347	03/96	Japan - Fujitsu		X	
	AQ	EP 0 810 666 A1	12/97	EPO - Oki Electric		N/A	
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
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APPLICANT Cem Basceri						FILING DATE Aug. 17, 2001		
GROUP 2813								
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	6,566,147 B2	05/03	Basceri et al.				
	AB							
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
	AL							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AM	EP 0 892 426 A2	01/99	EPO - Ramtron			N/A	
	AN	JP 2000091333	03/00	Japan			X	
	AO	WO 01/16395	03/01	WIPO - Micron			N/A	
	AP							
	AQ							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AR							
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	AT							
EXAMINER				DATE CONSIDERED				
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